

00862.023488



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Haruhito ONO et al. ) : Examiner: N. Wells  
Application No.: 10/787,082 ) : Group Art Unit: 2881  
Filed: February 27, 2004 ) : Confirmation No.: 4298  
For: DEFLECTOR, METHOD OF MANUFACTURING ) : Allowed: February 16, 2005  
DEFLECTOR, AND CHARGED PARTICLE BEAM : April 12, 2005  
EXPOSURE APPARATUS USING DEFLECTOR )

**Mail Stop Issue Fee**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

LETTER TRANSMITTING CORRECTED FORMAL DRAWINGS

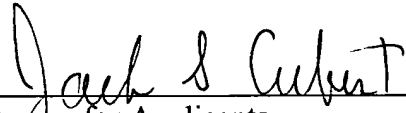
Sir:

Transmitted herewith are four (4) formal drawing replacement sheets, corrected Figures 1-4B, to be substituted for the corresponding drawing sheets currently on file in the above-identified application.

Figures 1-4B incorporate the changes required by the Examiner in the Notice of Allowability dated February 16, 2005.

Applicants' attorney, Steven E. Warner, may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

Respectfully submitted,

A handwritten signature in cursive script, reading "Jack S. Cubert", written over a horizontal line.

Attorney for Applicants

Jack S. Cubert

Registration No. 24,245

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